Early Warning System

IADB-RG-T3509

Promoting Gender Equality, Diversity and Inclusion in the Private Sector

Quick Facts

Financial Institutions	Inter-American Development Bank (IADB)
Status	Approved
Bank Risk Rating	C
Voting Date	2019-11-21
Borrower	Regional
Sectors	Law and Government, Technical Cooperation
Investment Type(s)	Grant
Project Cost (USD)	$ 1.00 million

Project Description

According to the Bank's website, this project finances technical cooperation to strengthen the capacity of public and private stakeholders to close organisational gender gaps and to facilitate the inclusion in equitable and fair terms of historically excluded populations. This includes indigeous and traditional peoples, African descendant populations, persons with disabilities and Lesbian, Gay, Bisexual, Transexual, Queer and other (LGBTQ+) individuals.

This technical assistance supports the public and private sectors in creating opportunities for these underrepresented populations.

Investment Description

- Inter-American Development Bank (IADB)

Contact Information

No contact information available at time of writing.

ACCOUNTABILITY MECHANISM OF IADB

The Independent Consultation and Investigation Mechanism (MICI) is the independent complaint mechanism and fact-finding body for people who have been or are likely to be adversely affected by an Inter-American Development Bank (IDB) or Inter-American Investment Corporation (IIC)-funded project. If you submit a complaint to MICI, they may assist you in addressing the problems you raised through a dispute-resolution process with those implementing the project and/or through an investigation to assess whether the IDB or IIC is following its own policies for preventing or mitigating harm to people or the environment. You can submit a complaint by sending an email to MICI@iadb.org. You can learn more about the MICI and how to file a complaint at http://www.iadb.org/en/mici/mici,1752.html (in English) or http://www.iadb.org/es/mici/mici,1752.html (Spanish).

Bank Documents

- RG-T3509 - TC Abstract [Original Source]